

US009142526B2

# (12) United States Patent Lin et al.

## (10) Patent No.: US 9,142,526 B2 (45) Date of Patent: Sep. 22, 2015

### (54) SEMICONDUCTOR PACKAGE WITH SOLDER RESIST CAPPED TRACE TO PREVENT UNDERFILL DELAMINATION

(71) Applicant: MediaTek Inc., Hsin-Chu (TW)

(72) Inventors: **Tzu-Hung Lin**, Zhubei (TW);

Ching-Liou Huang, Qionglin Township, Hsinchu County (TW); Thomas Matthew Gregorich, San Diego, CA

(US)

(73) Assignee: MEDIATEK INC., Hsin-Chu (TW)

(\*) Notice: Subject to any disclaimer, the term of this

patent is extended or adjusted under 35 U.S.C. 154(b) by 0 days.

(21) Appl. No.: 14/103,066

(22) Filed: **Dec. 11, 2013** 

(65) **Prior Publication Data** 

US 2014/0091481 A1 Apr. 3, 2014

### Related U.S. Application Data

- (63) Continuation of application No. 13/332,658, filed on Dec. 21, 2011, now Pat. No. 8,633,588.
- (51) Int. Cl.

  H01L 23/00 (2006.01)

  H01L 23/31 (2006.01)

  H01L 21/56 (2006.01)

  H01L 23/498 (2006.01)

  H01L 23/50 (2006.01)

(52) U.S. Cl.

2224/131 (2013.01); H01L 2224/16238 (2013.01); H01L 2224/26175 (2013.01); H01L 2224/2919 (2013.01); H01L 2224/32225 (2013.01); H01L 2224/73204 (2013.01); H01L 2224/81193 (2013.01); H01L 2224/81815 (2013.01); H01L 2224/83855 (2013.01)

### (58) Field of Classification Search

### (56) References Cited

#### U.S. PATENT DOCUMENTS

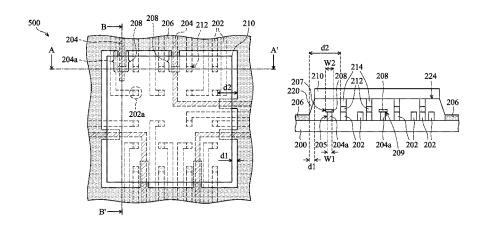
| 5,925,931<br>6,061,248<br>6,297,553<br>6,855,573 | A<br>B1<br>B2 | 5/2000<br>10/2001<br>2/2005      |  |  |  |  |  |
|--|---------------|----------------------------------|--|--|--|--|--|
| RE39,603   | Е             | 5/2007 Kata et al<br>(Continued) |  |  |  |  |  |

Primary Examiner — Eva Y Montalvo
Assistant Examiner — Grant Withers
(74) Attorney, Agent, or Firm — McClure, Qualey & Rodack, LLP

### (57) ABSTRACT

The invention provides a semiconductor package. The semiconductor package includes a substrate. A first conductive trace is disposed on the substrate. A first conductive trace disposed on the substrate. A semiconductor die is disposed over the first conductive trace. A solder resist layer that extends across an edge of the semiconductor die is also included. Finally, an underfill material is provided that fills a gap between the substrate and the semiconductor die.

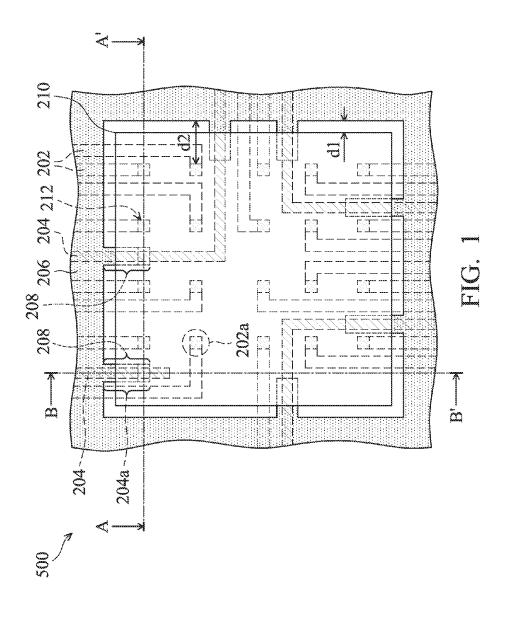
### 20 Claims, 4 Drawing Sheets

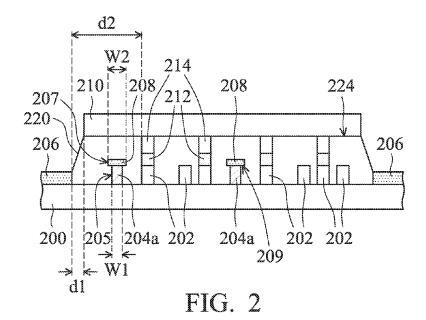


# **US 9,142,526 B2**Page 2

| (56)   | Referen  | ces Cited  |   | 2011/0241203 A1<br>2011/0248399 A1   | 10/2011<br>10/2011   | Nakasato et al.<br>Pendse |
|--|--|--|---|--|--|---------------------------|
| J  | J.S. PATENT  | DOCUMENTS  |   | 2011/0272799 A1  | 11/2011  |                           |
| 7,319,276 I 7,388,281 I 7,474,006 I 7,508,073 I 7,569,935 I 7,932,615 I 8,222,738 I 8,513,818 I 2003/0134455 / 2005/0070084 / 2006/0157845 / 2006/0278999 / 2007/0187824 / 2008/0067661 / 2008/0088016 / 2008/0088016 / 2009/0184419 / 2009/0250811 / 2010/0007015 / 2011/0047008 / 2011/0074008 / 2011/0074008 / 2011/007408 / 2011/0133334 / | B2 1/2008<br>B2 6/2008<br>B2 7/2009<br>B1 8/2009<br>B2 3/2009<br>B2 4/2011<br>B2 7/2012<br>B2* 8/2013<br>A1 7/2003<br>A1 6/2004<br>A1 3/2005<br>A1 1/2006<br>A1* 5/2007<br>A1 8/2007<br>A1 8/2007<br>A1 4/2008<br>A1 4/2008<br>A1 10/2009<br>A1 1/2010<br>A1 3/2011<br>A1 3/2011 | Hsu et al. Krueger et al. Maeda Nakamura et al. Fan Rinne Ota et al. Hagihara Cheng et al. Tay et al. Hsu et al. Terui Hsu et al. Choi Anzai Kawabata Ho et al. Pendse Pendse Gallegos Hsu et al. Hsieh Pendse | 257/781<br>257/786<br>257/778<br>257/778<br>257/778 | 2011/02/2/99 A1 2011/0278723 A1* 2011/0285013 A1 2011/0309672 A1* 2011/0309500 A1 2012/0007232 A1 2012/0032322 A1 2012/0032343 A1 2012/0032343 A1 2012/0133042 A1 2012/0133042 A1 2012/0153463 A1 2012/0241945 A9 2012/0241946 A9 2012/0247941 A1 2012/0273941 A1 2012/0273943 A1 2012/0273943 A1 2012/0273943 A1 2012/0273943 A1 2012/02313240 A1* 2012/0313240 A1* 2012/0319272 A1 2012/0319273 A1 | 11/2011<br>11/2011<br>12/2011<br>1/2012<br>2/2012<br>2/2012<br>2/2012<br>3/2012<br>5/2012<br>5/2012<br>6/2012<br>8/2012<br>9/2012<br>9/2012<br>11/2012<br>11/2012<br>11/2012 | Nishimura et al           |
| 2011/0133334 Z<br>2011/0186986 Z<br>2011/0198753 Z   | A1 8/2011  | Chuang et al. Holland  | 231/131   | 2013/0026621 A1<br>2013/0026628 A1   | 1/2013<br>1/2013   | Tsai et al.<br>Pendse     |
| 2011/0198733 Z<br>2011/0204511 Z   |  | Beddingfield et al.  |   | * cited by examiner  |  |                           |

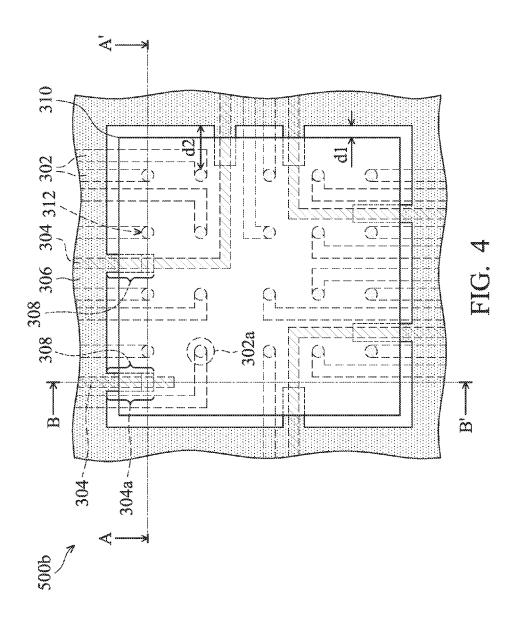
Sep. 22, 2015

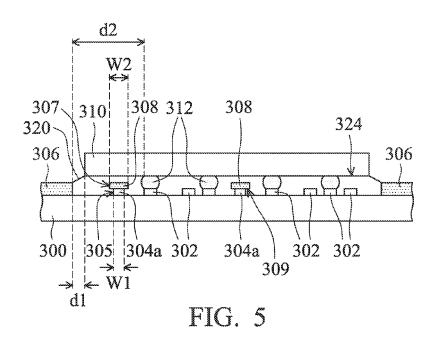




204 206 204 202 202 206 FIG. 3

Sep. 22, 2015





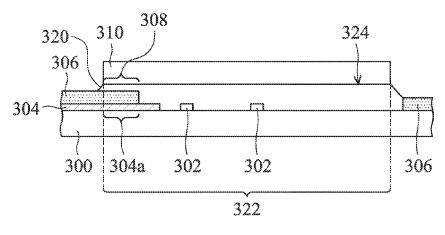


FIG. 6

1

### SEMICONDUCTOR PACKAGE WITH SOLDER RESIST CAPPED TRACE TO PREVENT UNDERFILL DELAMINATION

### CROSS REFERENCE TO RELATED APPLICATIONS

This application is a Continuation of U.S. patent application Ser. No. 13/332,658, filed on Dec. 21, 2011, now U.S. Pat. No. 8,633,588, the entirety of which is incorporated by reference herein.

### BACKGROUND OF THE INVENTION

### 1. Field of the Invention

The present invention relates to a semiconductor package, and in particular, to a solder resist layer design of a flip chip package.

### 2. Description of the Related Art

For the conventional flip chip package, it is well known that the underfill protects the conductive bumps by considerably reducing the stress to the conductive bumps. However, the underfill itself is subject to shear or peeling stress and consequently, may induce failure modes. For instance, an imperfect underfill with voids or microcracks will produce cracks or 25 delamination under temperature cycling conditions.

Delamination at bimaterial interfaces such as the underfill and conductive traces, driven by coefficient of thermal expansion (CTE) mismatching between organic underfills and inorganic conductive traces, is one of failure modes. Once the underfill delamination, occurs, failure usually results from conductive bump fatigue cracks because of the loss of the underfill protection and stress concentration arising from the underfill delamination.

Thus, a novel flip chip package without the underfill  $^{35}$  delamination is desirable.

### BRIEF SUMMARY OF INVENTION

A semiconductor package is provided. An exemplary 40 embodiment of a semiconductor package includes a substrate. A first conductive trace is disposed on the substrate. A solder resist layer is disposed on the substrate, having an extending portion covering a portion of the first conductive trace, wherein a width of the extending portion of the solder 45 resist layer is larger than that of the portion of the first conductive trace. A semiconductor die is disposed over the first conductive trace.

Another exemplary embodiment of a semiconductor package includes a substrate. A first conductive trace is disposed on the substrate, having an extending portion covering a portion of the first conductive trace, wherein the extending portion of the solder resist layer has a vertical sidewall extruding over to an adjacent vertical sidewall of the portion of the first conductive trace. A semiconductor die is disposed over the first conductive trace.

A detailed description is given in the following embodiments with reference to the accompanying drawings.

### BRIEF DESCRIPTION OF DRAWINGS

The invention can be more fully understood by reading the subsequent detailed description and examples with references made to the accompanying drawings, wherein:

FIG. 1 shows a top view of one exemplary embodiment of a semiconductor package of the invention.

2

FIG. 2 shows a cross section along line A-A' of FIG. 1.

FIG. 3 shows a cross section along line B-B' of FIG. 1.

FIG. 4 shows a top view of another exemplary embodiment of a semiconductor package of the invention.

FIG. 5 shows a cross section along line A-A' of FIG. 4.

FIG. 6 shows a cross section along line B-B' of FIG. 4.

### DETAILED DESCRIPTION OF INVENTION

The following description is a mode for carrying out the invention. This description is made for the purpose of illustrating the general principles of the invention and should not be taken in a limiting sense. The scope of the invention is best determined by reference to the appended claims. Wherever possible, the same reference numbers are used in the drawings and the descriptions to refer the same or like parts.

The present invention will be described with respect to particular embodiments and with reference to certain drawings, but the invention is not limited thereto and is only limited by the claims. The drawings described are only schematic and are non-limiting. In the drawings, the size of some of the elements may be exaggerated and not drawn to scale for illustrative purposes. The dimensions and the relative dimensions do not correspond to actual dimensions to practice of the invention.

FIG. 1 shows a top view of one exemplary embodiment of a semiconductor package 500a of the invention. FIG. 2 shows a cross section along line A-A' of FIG. 1. FIG. 3 shows a cross section along line B-B' of FIG. 1. One exemplary embodiment of a semiconductor package 500a is a flip chip package using copper pillars connecting a semiconductor die and a substrate. As shown in FIGS. 1-3, one exemplary embodiment of a semiconductor package 500a comprises a substrate 200 with first conductive traces 202 and second conductive traces 204 disposed thereon. In one embodiment, the substrate 200 may be formed of by semiconductor materials such as silicon, or organic materials such as bismaleimide triacine, (BT), polyimide or ajinomoto build-up film (ABF). In one embodiment, the first conductive trace 204 and the second conductive trace 202 may comprise signal traces or ground traces, which are used for input/output (I/O) connections of a semiconductor die 210 mounted directly onto the substrate 200. In this embodiment, each of the first conductive traces 204 serves as a signal/ground trace segment for routing, and each of the second conductive traces 202 has a portion 202a as a pad region of the substrate 200.

Next, still referring to FIGS. 1-3, a solder resist layer 206 is conformably formed covering the substrate 200 by a deposition method and then the solder resist layer 206 is subjected to a patterning process. After the patterning process, the solder resist layer 206, except for extending portions 208, exposes an overlapping region between a subsequently mounted semiconductor die 210 and the substrate 200. It is noted that the extending portions 208 of the solder resist layer 206 extends along the first conductive trace 204 and covering a portion of the first conductive trace 204. Also, the solder resist layer 206, except for extending portions 208, is disposed away from the subsequently mounted semiconductor die 210 by a distance d1. In one embodiment, the solder resist layer 206 may com-60 prise solder mask materials, oxide, nitride, or oxynitride. As shown in FIG. 2, the extending portions 208 of the solder resist layer 206 covers a portion 204a of the first conductive trace 204. It is noted that a width W2 of the extending portion 208 of the solder resist layer 206 is designed to be larger than a width W1 of the portion 204a of the first conductive trace 204, so that a portion of a bottom surface 209 of the extending portion 208 of the solder resist layer 206 is exposed from the 3

204a of the first conductive trace 204, and the extending portion 208 of the solder resist layer 206 has a vertical side-wall 207 extruding over to an adjacent vertical sidewall 205 of the portion 204a of the first conductive trace 204. Therefore, the extending portion 208 and the portion 204a of the first 5 conductive trace 204 collectively have a T-shaped cross section.

Next, a dry film photoresist or a liquid photoresist (not shown) is entirely laminated on the substrate **200**. Next, the dry film photoresist/liquid photoresist is patterned by a photolithography process comprising an exposure step and a development step to form openings (not shown) respectively over the portions (pad regions) **202***a* of the second conductive traces **202**, so that formation positions of a subsequently formed conductive pillar may be defined.

Then, the conductive pillars 212 are respectively formed on the portions (pad regions) 202a of the second conductive traces 202, filling the openings of the dry film photoresist/ liquid photoresist. Alternatively, conductive buffer layers (not shown) formed of Ni may be formed between the conductive 20 pillars 212 and the portions (pad regions) 202a of the second conductive traces 202, and the conductive buffer layers may serve as seed layers, adhesion layers and barrier layers for the conductive pillars 212 formed thereon. In one embodiment, the conductive pillars 212 are used as a solder joint for a 25 subsequently formed conductive bump, which transmits input/output (I/O), ground or power signals of the semiconductor die 210, formed thereon. Therefore, the conductive pillars 212 may help to increase the mechanical strength of the bump structure. In one embodiment, the conductive pil- 30 lars 212 may be formed of copper. Next, the dry film photoresist/liquid photoresist is removed by a stripping process such as a wet etching process using a suitable etchant.

Next, still referring to FIGS. 1-3, the semiconductor die 210 has a plurality of conductive bumps 214 formed on bond 35 pads (not shown) of the semiconductor die 210 mounted on the substrate 200. The conductive bumps 214 respectively connect to the portions (pad regions) 202a of the second conductive traces 202 through the conductive pillars 212 therebetween. As shown in FIG. 1, the solder resist layer 206 40 is disposed away from the portions (pad regions) 202a of the second conductive traces 202, which overlap with the conductive pillars 212, by at least a distance d2. As shown in FIG. 3, the extending portion 208 of the solder resist layer 206 is below the semiconductor die 210, over a bottom surface 224 45 of the semiconductor die 210 and within a projection area 222 of the semiconductor die 210.

Next, referring to FIGS. 2-3, an underfill material 220 may flow to fill a gap between the substrate 200 and the semiconductor die 210 and cover the solder resist layer 206 via capillary action by a dispensing method to compensate for differing coefficients of thermal expansion (CTE) between the substrate, the conductive traces and the semiconductor die. The underfill material 220 is then cured. In one embodiment of the invention, the portion of the bottom surface 209 of the extending portion 208 of the solder resist layer 206 is wrapped by the underfill material 220. After the aforementioned processes, one exemplary embodiment of a semiconductor package 500a is completely formed.

FIG. 4 shows a top view of one exemplary embodiment of 60 a semiconductor package 500b of the invention. FIG. 5 shows a cross section along line A-A' of FIG. 4. FIG. 6 shows a cross section along line B-B' of FIG. 4. One exemplary embodiment of a semiconductor package 500b is a flip chip package using solder bumps but not copper pillars for a connection 65 between a semiconductor die and a substrate. As shown in FIGS. 4-6, one exemplary embodiment of a semiconductor

4

package 500b comprises a substrate 300 with first conductive traces 302 and second conductive traces 304 disposed thereon. In one embodiment, the substrate 300 may be formed of by semiconductor materials such as silicon, or organic materials such as bismaleimide triacine, (BT), polyimide or ajinomoto build-up film (ABF). In one embodiment, the first conductive trace 304 and the second conductive trace 302 may comprise signal traces or ground traces, which are used for input/output (I/O) connections of a semiconductor die 310 mounted directly onto the substrate 300. In this embodiment, each of the first conductive traces 304 serves as a signal/ground trace segment for routing, and each of the second conductive traces 302 has a portion 302a as a pad region of the substrate 300.

Next, still referring to FIGS. 4-6, a solder resist layer 306 is conformably formed covering the substrate 300 by a deposition method and then the solder resistlayer 306 is subjected to a patterning process. After the patterning process, the solder resistlayer 306, except for extending portions 308, exposes an overlapping region between a subsequently mounted semiconductor die 310 and the substrate 300. It is noted that the extending portions 308 of the solder resist layer 306 extends along the first conductive trace 304 and covering a portion of the first conductive trace 304. Also, the solder resist layer 306, except for extending portions 308, is disposed away from the subsequently mounted semiconductor die 310 by a distance d1. In one embodiment, the solder resist layer 306 may comprise solder mask materials, oxide, nitride, or oxynitride. As shown in FIG. 5, the extending portions 308 of the solder resist layer 306 covers a portion 304a of the first conductive trace 304. It is noted that a width W2 of the extending portion 308 of the solder resist layer 306 is designed to be larger than a width W1 of the portion 304a of the first conductive trace 304, so that a portion of a bottom surface 309 of the extending portion 308 of the solder resist layer 306 is exposed from the 304a of the first conductive trace 304, and the extending portion 308 of the solder resist layer 306 has a vertical sidewall 307 extruding over to an adjacent vertical sidewall 305 of the portion 304a of the first conductive trace 304. Therefore, the extending portion 308 and the portion 304a of the first conductive trace 304 collectively have a T-shaped cross sec-

Next, referring to FIGS. 4-6, a solder printing process is performed to form solder paste patterns (not shown) on the portions (pad regions) 302a of the second conductive traces 302. Next, a semiconductor die 310 having a plurality bond pads (not shown) is mounted on the substrate 300. Bond pads (not shown) of the semiconductor die 310 respectively connect the solder paste patterns. Next, a reflow process and a cooling process are performed in sequence, so that the solder paste patterns are transformed into solder bumps 312 connecting the portions (pad regions) 302a of the second conductive traces 302 of the substrate 300 and the bond pads (not shown) of the semiconductor die 310. As shown in FIG. 4, the solder resist layer 306 is disposed away from the portions (pad regions) 302a of the second conductive traces 302, which overlap with the solder bumps 312, by at least a distance d2. As shown in FIG. 6, the extending portion 308 of the solder resist layer 306 is below the semiconductor die 310, over a bottom surface 324 of the semiconductor die 310 and within a projection area 322 of the semiconductor die 310.

Next, referring to FIGS. 5-6, an underfill material 320 may flow to fill a gap between the substrate 300 and the semiconductor die 310 and cover the solder resist layer 306 via capillary action by a dispensing method to compensate for differing coefficients of thermal expansion (CTE) between the substrate, the conductive traces and the semiconductor die.

5

The underfill material 320 is then cured. In one embodiment of the invention, the portion of the bottom surface 309 of the extending portion 308 of the solder resist layer 306 is wrapped by the underfill material 320. After the aforementioned processes, another exemplary embodiment of a semi- 5 conductor package 500b is completely formed.

Some advantages of exemplary embodiments of a semiconductor package 500a and 500b of the invention are described in the following. The underfill material wraps the portion of the bottom surface of the extending portion of the solder resist layer, which has a wider width than the portion of the first conductive trace, so that the underfill material may be anchored with a T-shaped feature formed by both the extending portion of the solder resist layer and the portion of the first conductive trace. Thus, the conventional underfill delamina- 15 tion problem occurring between the conductive trace and the underfill material is improved. Also, the extending portion of the solder resist layer only extends into a projection area of the die to cover a portion of the first conductive trace, and the remaining portion of the solder resist layer is disposed away 20 from the semiconductor die by a distance, so that the semiconductor package still has enough space to allow the underfill material to flow to fill the gap between the substrate and the semiconductor die. Therefore, the extending portion of the solder resist layer does not affect the performance of the 25 dispensing process. Moreover, exemplary embodiments of a semiconductor package can be used in many types of package methods. For example, a gap between the substrate and the semiconductor die can be filled with a molding compound only. Alternatively, the gap between the substrate and the 30 semiconductor die can be filled with a molding compound and an underfill material. Further, the gap between the substrate and the semiconductor die can be filled with an underfill material only.

While the invention has been described by way of example 35 edge of the semiconductor die. and in terms of the preferred embodiments, it is to be understood that the invention is not limited to the disclosed embodiments. To the contrary, it is intended to cover various modifications and similar arrangements (as would be apparent to those skilled in the art). Therefore, the scope of the appended 40 claims should be accorded the broadest interpretation so as to encompass all such modifications and similar arrangements.

What is claimed is:

- 1. A semiconductor package, comprising:
- a substrate:
- a first conductive trace disposed on the substrate;
- a semiconductor die disposed over the first conductive
- a solder resist layer, wherein a portion of the solder resist layer extends across an edge of the semiconductor die; 50
- an underfill material filling a gap between the substrate and the semiconductor die, wherein a plurality of strips of the solder resist layer extend from outside an edge of the semiconductor die to a region between the semiconduc- 55 tor die and the substrate.
- 2. The semiconductor package as claimed in claim 1, wherein the portion of the solder resist layer covers a portion of the first conductive trace, and wherein a width of the portion of the solder resist layer is larger than that of the 60 portion of the first conductive trace from a top view.
- 3. The semiconductor package as claimed in claim 1, wherein the portion of the solder resist layer is below the semiconductor die and within a projection area of the semiconductor die.
- 4. The semiconductor package as claimed in claim 1, wherein the portion of the solder resist layer has a vertical

sidewall extruding over an adjacent vertical sidewall of the portion of the first conductive trace from a top view.

- 5. The semiconductor package as claimed in claim 1, wherein the portion of the solder resist layer extends along the first conductive trace and over a bottom surface of the semiconductor die.
- 6. The semiconductor package as claimed in claim 1, wherein the portion of the solder resist layer extends from outside an edge of the semiconductor die to a region between the semiconductor die and the substrate.
- 7. The semiconductor package as claimed in claim 1, wherein the portion of the solder resist layer is covered by the underfill material.
  - 8. A semiconductor package, comprising:
  - a substrate;
  - a first conductive trace disposed on the substrate;
  - a semiconductor die disposed over the first conductive trace:
  - a solder resist layer, wherein a portion of the solder resist layer extends from outside an edge of the semiconductor die to a region between the semiconductor die and the substrate; and
  - an underfill material filling a gap between the substrate and the semiconductor die, wherein a plurality of strips of the solder resist layer extend from outside an edge of the semiconductor die to a region between the semiconductor die and the substrate.
- 9. The semiconductor package as claimed in claim 8, wherein the portion of the solder resist layer covers a portion of the first conductive trace, and wherein a width of the portion of the solder resist layer is larger than that of the portion of the first conductive trace from a top view.
- 10. The semiconductor package as claimed in claim 8, wherein the portion of the solder resist layer extends across an
- 11. The semiconductor package as claimed in claim 8, wherein the portion of the solder resist layer is covered by the underfill material.
  - 12. A semiconductor package, comprising:
  - a substrate:
  - a first conductive trace disposed on the substrate;
  - a semiconductor die disposed over the first conductive
  - an underfill material filling a gap between the substrate and the semiconductor die; and
  - a solder resist layer, wherein a portion of the solder resist layer is covered by the underfill material, wherein a plurality of strips of the solder resist layer extend from outside an edge of the semiconductor die to a region between the semiconductor die and the substrate.
- 13. The semiconductor package as claimed in claim 12, wherein the portion of the solder resist layer covers a portion of the first conductive trace, and wherein a width of the portion of the solder resist layer is larger than that of the portion of the first conductive trace from a top view.
- 14. The semiconductor package as claimed in claim 12, wherein the portion of the solder resist layer extends across an edge of the semiconductor die.
- 15. The semiconductor package as claimed in claim 12, wherein the portion of the solder resist layer extends from outside an edge of the semiconductor die to a region between the semiconductor die and the substrate.
  - 16. A semiconductor package, comprising:
  - a substrate:
  - a first conductive trace disposed on the substrate;
  - a semiconductor die disposed over the first conductive

a solder resist layer, wherein a plurality of strips of the solder resist layer extend from outside an edge of the semiconductor die to a region between the semiconductor die and the substrate; and

7

an underfill material filling a gap between the substrate and 5 the semiconductor die.

- 17. The semiconductor package as claimed in claim 16, wherein a plurality of the strips of the solder resist layer covers a portion of the first conductive trace, and wherein a width of the portion of the solder resist layer is larger than that 10 of the portion of the first conductive trace from a top view.
- 18. The semiconductor package as claimed in claim 16, wherein a plurality of the strips of the solder resist layer extends across an edge of the semiconductor die.
- 19. The semiconductor package as claimed in claim 16, 15 wherein a plurality of the strips of the solder resist layer extends from outside an edge of the semiconductor die to a region between the semiconductor die and the substrate.
- 20. The semiconductor package as claimed in claim 16, wherein a plurality of the strips of the solder resist layer is 20 covered by the underfill material.

\* \* \* \* \*

8